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U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

**REQUEST FOR EXTENSION
OF TIME PURSUANT TO
37 C.F.R. § 1.136(a)**

Docket Number:

10191/1614

Conf. No.:

3872

Application Number
09/720,720

Filing Date
February 28, 2001

Examiner
Binh TRAN

Art Unit
1765

Invention Title
**METHOD FOR ELIMINATING DEFECTS
IN SILICON ELEMENTS THROUGH
SELECTIVE ETCHING**

Inventor:
Richard SPITZ et al.

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

Dated: June 26, 2003

Reg. No. 36,197

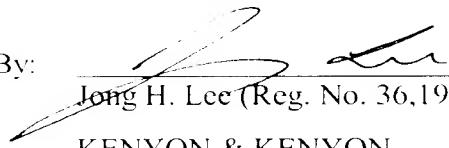
Signature: 

Jong H. Lee

Applicants respectfully request a one-month extension of time in which to respond to the office action dated March 17, 2003, for which a response period expiring on June 17, 2003, was set. The extended period expires on July 17, 2003.

1. The Commissioner is hereby authorized to charge payment of the 37 C.F.R. § 1.136(a) extension fee of **\$110.00** to the Deposit Account of **Kenyon & Kenyon**, Deposit Account number **11-0600**. The office is also authorized to charge any additional fees, or credit overpayments, associated with this paper to Deposit Account **11-0600**.
2. A duplicate copy of this form is enclosed.

Dated: June 26, 2003

By: 

Jong H. Lee (Reg. No. 36,197)

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